

INTERNATIONAL  
GEMOLOGICAL  
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

July 18, 2024

IGI Report Number

DESCRIPTION

Shape and Cutting Style

Measurements

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

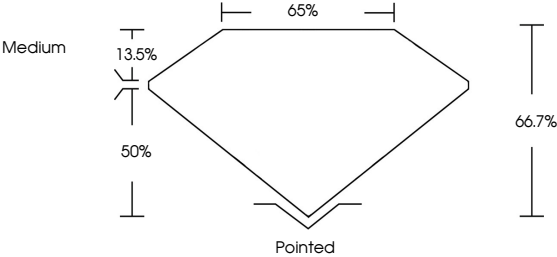
Inscription(s)

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

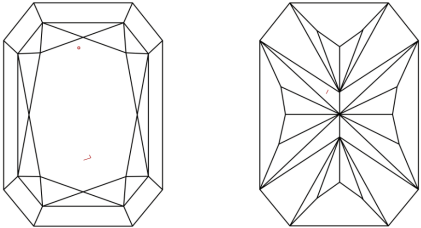
LG644475146

Report verification at igi.org

PROPORTIONS




CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

Sample Image Used



COLOR



D E F G H I J

Faint Very Light Light

CLARITY

IF VS 1-2 VS 1-2 SI 1-2 I 1-3


Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included



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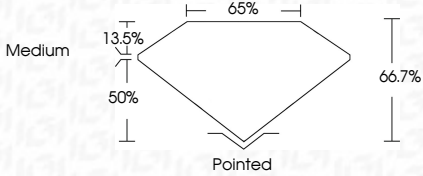
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IGI

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IGI Report No LG644475146

CUT CORNERED RECT. MODIFIED BRILLIANT

8.77 X 6.19 X 4.13 MM

Carat Weight

Color Grade

Clarity Grade

Depth

Table

Girdle

Culet

Polish

Symmetry

Fluorescence

Inscription(s)

1.97 CARAT

F

VS 1

66.7%

65%

Medium

Pointed

EXCELLENT

EXCELLENT

NONE

IGI LG644475146

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